

Illumination effects in electron irradiated 6H n-type SiC observed by positron annihilation spectroscopy

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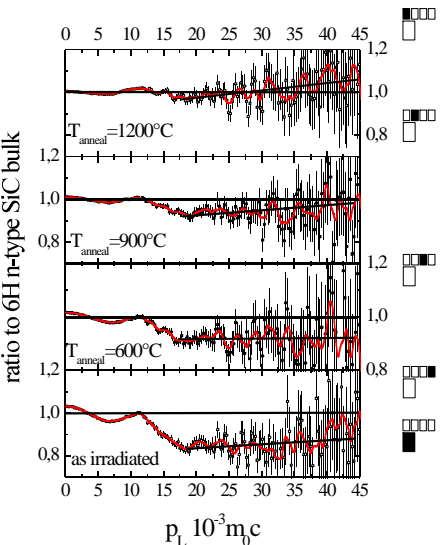
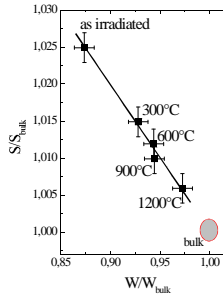
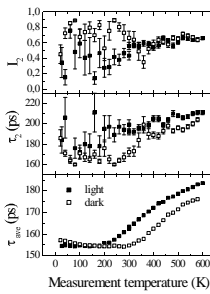
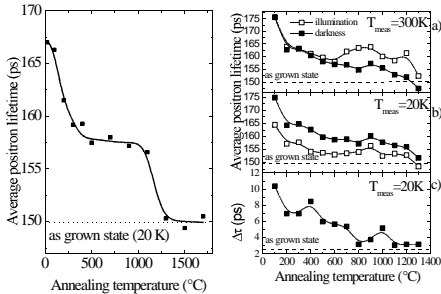
Introduction

- SiC - Key material for high power and high frequency electronic devices
- Ion implantation - standard procedure for selective doping of SiC
- Electron irradiation - controlling of minority carrier lifetime
- Identification of vacancy-type defects induced by electron irradiation
- E1/E2 level (negative-U behavior DLTS [Hem99]) - related to vacancy-type defects?
- Observation of metastable defect [Hem99a] through optical illumination with white and monochromatic light

Experimental

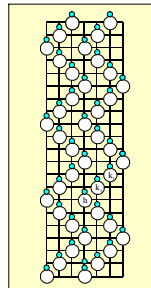
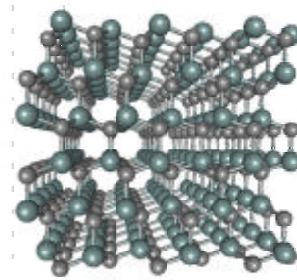
- N-doped SiC bulk wafers were purchased by Nippon Steel Company [N]= $1 \times 10^{17} \text{ cm}^{-3}$
- Samples were irradiated in Japan Atomic Energy Research Institute (JAERI) with 2 MeV electrons for two different doses ($1 \times 10^{17} \text{ cm}^{-2}$ and $3 \times 10^{17} \text{ cm}^{-2}$) at room temperature
- Sample size 5x5mm²
- Positron source: ²²NaCl (10-90 μ Ci)
- Conventional fast positron lifetime and Doppler broadening spectrometer (FWHM =260ps and 1 keV)
- Monochromatic light available: 0.3-3.2 eV
- Annealing proceeded up to 1300°C under vacuum and above under ambient argon atmosphere

Annealing



- 2 step annealing for electron irradiation (dose: $1 \times 10^{17} \text{ cm}^{-2}$)
First step: annealing of Frenkel pairs and carbon vacancy
Second step: annealing of complexes with silicon vacancies
Some vacancy type defects remain after 1700°C heat treatment
- Four step annealing was observed
First step: annealing of Frenkel pairs
Second step: carbon vacancies become mobile
Third step: silicon vacancies become mobile and form complexes
Fourth step: annealing of most defects introduced by electron irradiation
- Decomposition of lifetime spectra for high dose irradiated sample and annealed at 800°C as a function of measurement temperature
- More than one defect act as a trapping center for a measurement temperature at 300K
- S- and W-parameter behavior indicates that one defect is main trapping center
- Coincidence Doppler broadening spectra for different annealing temperatures
- Slight increase of high momentum spectrum indicate, that the vacancies are surrounded by C-atoms (similar behavior from theory) \rightarrow silicon vacancy

Structure, material

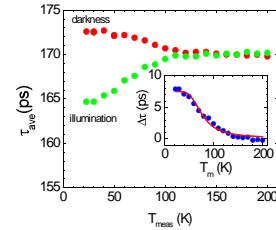


6H SiC structure
carbon sites \bullet
silicon sites \circ

Properties:

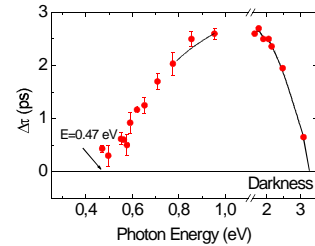
- Band gap at the temperature 5K: 3.101 eV
- Hexagonality :33%
- Lattice parameter:
a = 3.0806 Å
c = 15.1173Å (297 K)
- Density $\rho = 3.211 \text{ g/cm}^3$
- Very low diffusion coefficient of dopants
- Great mechanical hardness

Illumination



- After illumination with white light a decrease of the average positron lifetime appears below 110 K
- The spectra decomposition shows a defect-related lifetime of 185 ps (V_{Si}) [Bra96] either in darkness or under illumination. The intensity decreases from 45% to 17% under illumination.
- The illumination effect appears also in as-grown material. The irradiation with 2 MeV was done to introduce additional Frenkel pairs.
- In the inset the difference of positron lifetime under illumination and darkness is presented. (the fitted Energy barrier: 32 meV)
- $\Delta\tau = \tau_{\text{dark}} - \tau_{\text{illum}}$

Illumination



- The data were fitted to the Lucovsky model [Luc65] which gives the cross section for electron transition from a localized state to a parabolic and isotropic band. The threshold energy is determined to be $E = 0.47 \text{ eV}$.
- Illumination effect disappears above 3eV due to direct transition of electrons from the valence band to the conduction band.
- Above 0.4 eV electrons are probably excited from localized levels to the conduction band. Thus, the charge state will change from negative to neutral.

Summary

- after irradiation with 2 MeV electrons, the illumination effect (difference of the average positron lifetime under illumination and in darkness in the as grown state was $\Delta\tau = 2.5 \text{ ps}$) in n-type 6H SiC increases
- most of induced defects annealed out at a temperature of 1400°C
- the decomposition of the lifetime spectra shows a defect-related positron lifetime similar to the silicon vacancies
- the observed threshold energy for the illumination effect (0.47eV) is higher than the measured energy level (DLTS: 0.3eV/0.4eV) for the E_1/E_2 defect

Literature

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